



Application Number: 10/006,462

Applicant(s): Steven R. Walther

Title Dose Uniformity Control For Plasma Doping
Systems

The following was/were received in the U.S. Patent & Trademark Office mail room on the date stamped hereon:

1. AMENDMENT
2. THREE-MONTH PETITION FOR EXTENSION OF TIME
3. RETURN POST CARD

Please date stamp this self-addressed, postage-paid card and Return to us. Thank you. (2000-026)

DOCKET NO: VSEA 26-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther
Serial No: 10/006,462
Confirmation No: 5689
Filed: December 4, 2001
For: DOSE UNIFORMITY CONTROL FOR PLASMA DOPING
SYSTEMS
Examiner: Michelle Crowell
Art Unit: 1763

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 14 day of May, 2004.


Cheryl Pucell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith are the following documents:

Amendment
 Three-month Petition for Extension of Time
 Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,
Steven R. Walther, Applicant

By: 

Mark A. Superko, Reg. No. 34,027
Varian Semiconductor Equipment
Associates, Inc.
35 Dory Rd.
Gloucester, Massachusetts 01930-2297
Telephone: (978) 282-5915

Docket No. VSEA 26-00